

INFORMATION DISCLOSURE STATEMENT		Atty. Docket No.: 52314US016		Serial No.: to be assigned			
		Applicant(s):Gunter A. Kohler et al.		Filing Date: even date herewith			
U.S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	SubClass	Filing Date if Appropriate
amc		3,503,859	03/31/70	Goncarovs et al.	204	165	05/02/67
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EXAMINER
A. Michelle Howell
Date Considered
02-04-03

*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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